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Complete If Known

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First Named Inventor Mehregany

Art Unit 1775

Examiner Name Archene A. Turner

Attorney Docket Number 29438/04001

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
A		Hwang, J-D et al, "Epitaxial Growth and Electrical Characteristics of Beta-SiC on Si by Low-Pressure Rapid Thermal Chemical Vapor Deposition." Japanese Journal of Applied Physics. Tokyo, JP, vol. 34, no. 3, Part 1, March 1995 (1995-03), pgs. 1447-1450. XP-000703002	
A		Sarro, P. M. et al., "Low-Stress PECVD SiC thin films for IC-compatible microstructures." Sensors and Actuators A, Elsevier Sequoia S.A., Lausanne, CH, vol. 67, no. 1-3, May 15, 1998, pgs. 175-180.	
A		Search Report for PCT/US2004/037064, published 9/12/2005.	

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